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04/25/2009

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Tois et al.
App. No	: 10/678,766
Filed	: October 2, 2003
For	: METHOD OF GROWING OXIDE THIN FILMS
Examiner	: Matthew J. Song
Art Unit	: 1792
Conf No.	: 1629

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on November 18, 2008 and is accompanied by a Request for Continued Examination and a request for a two-month extension of time. Applicants respectfully request entry of the following amendments and consideration of the subsequent remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Summary of Interview begins on page 7 of this paper.

Remarks begin on page 8 of this paper.